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Lin Li
Kevin P. Thompson
Ligong Zheng
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Contents

vii	<i>Authors</i>
ix	<i>Conference Committee</i>
xi	<i>Introduction</i>

OPTICAL DESIGN AND MANUFACTURING TECHNOLOGIES

9676 02	Satellite-rocket docking ring recognition method based on mathematical morphology [9676-3]
9676 03	Optimized design and research of secondary microprism for dense array concentrating photovoltaic module [9676-4]
9676 04	Optical design of temperature self-adaptive dual-field infrared system [9676-5]
9676 05	A videometrics method of cooperative object pose-measurement [9676-7]
9676 06	Research on auto-calibration technology of the image plane's center of 360-degree and all round looking camera [9676-9]
9676 07	Infrared zoom lens design based on target correlation recognition and tracking [9676-11]
9676 08	Starlight emergence angle error analysis of star simulator [9676-12]
9676 09	The measurement of pointing accuracy of two-dimensional scan mirror [9676-13]
9676 0A	Magnetically tunable multi-way splitters based on unidirectional properties of magnetic metamaterials [9676-14]
9676 0B	Sensor fault diagnosis for fast steering mirror system based on Kalman filter [9676-15]
9676 0C	Spectral calibration of programmable imaging spectrometer [9676-20]
9676 0D	Optical design of MWIR detection system for near-space infrared detecting [9676-21]
9676 0E	Open loop liquid crystal adaptive optics systems: progresses and results [9676-22]
9676 0F	Design of the relay lens for infrared system coupled with imaging fiber bundle [9676-23]
9676 0G	Analysis of the imaging performance of panoramic annular lens with conic conformal dome [9676-24]
9676 0H	The research of calibration method on lens-tilt displacement transmission-type system based on the aberration bounded model [9676-25]

9676 0I	Research on surface control technology of precession bonnet polishing for optical processing [9676-26]
9676 0J	Polarization-difference imaging of objects in smoke environment [9676-27]
9676 0K	Design of laser beam expander in underwater high-repetition-rate range-gated imaging system [9676-28]
9676 0L	Research on the space-variant image sensor based on optical method [9676-30]
9676 0M	Research on precision windowed track mode for in-orbit calibration on star tracker [9676-31]
9676 0N	Design of collimating and rearrangement systems of laser diode array beam [9676-32]
9676 0O	Research on non-direct reflection columnar microstructure [9676-33]
9676 0P	Design and fabrication of an elliptical micro-lens array with grating for laser safety [9676-35]
9676 0Q	The application of frequency characteristics test in fast control mirror system [9676-37]
9676 0R	Analysis and judgment of key issues in data process for optical tracking and measurement [9676-38]
9676 0S	Novel PbS detector chip pattern with extinction function [9676-41]
9676 0T	Application of independent component analysis in target trajectory prediction based on moving platform [9676-42]
9676 0U	The effect of physical parameters of inertial stabilization platform on disturbance rejection ability and its improvement method [9676-43]
9676 0V	An application of PECHAN prism in infrared search and track system [9676-45]
9676 0W	Thermal/structural/optical integrated design for optical window of a high-speed aerial optical camera [9676-46]
9676 0X	Lens customization method to minimize aberration in integral imaging [9676-48]
9676 0Y	Optical system design of dual-spectrum autocollimator [9676-51]
9676 0Z	Design of infrared diffractive telescope imaging optical systems [9676-52]
9676 10	The study of laser beam riding guided system based on 980nm diode laser [9676-53]
9676 11	Research on large spatial coordinate automatic measuring system based on multilateral method [9676-57]
9676 12	Feasibility analysis of digital single lens reflex applied in the field of aerospace measurement [9676-59]

- 9676 13 **Efficient manufacturing technology of metal optics [9676-61]**
- 9676 14 **An optical system design that converts a Gaussian to a flattop annular beam [9676-62]**
- 9676 15 **Optical system design for lens with large relative aperture [9676-67]**
- 9676 16 **The finite element analysis of zoom optical system with no moving parts [9676-68]**
- 9676 17 **Anodic fluoride passivation of InAs/GaSb type II superlattice infrared detector [9676-69]**
- 9876 1A **3D model-based detection and tracking for space autonomous and uncooperative rendezvous [9676-6]**

Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

An, Chao, 09	Kang, Yao, 11
Bai, Jian, 0G	Kang, Yuanyuan, 0R
Bao, Long-xiang, 0I	Kim, Jonghyun, 0X
Bao, Qiliang, 0B	Lee, Byoung-ho, 0X
Cao, Xiancun, 17	Lee, W. B., 0P
Cao, Zhao-liang, 0E	Li, Binkang, 0J
Chan, C. Y., 0P	Li, Chaochen, 14
Chen, Bingzhen, 03	Li, Fu, 0F
Chen, Fengjin, 0S	Li, Gang, 0D
Chen, Wuhe, 0A	Li, Gang, 0J
Cui, Shuhua, 0R	Li, Jianshuan, 11
Deng, Chao, 0T, 0U	Li, Jing, 0I
Deng, Xiangrui, 11	Li, L. H., 0P
Dong, L. H., 0O, 0P	Li, Li, 0H
Du, Guojun, 0C	Li, Lianfu, 11
Duan, Jin, 07	Li, Lin, 0L, 16
Duan, Jing, 0D	Li, Manliang, 12
Fang, Tao, 0N	Li, Ming, 04
Fei, Jiaqi, 15	Li, Wansong, 0L
Feng, Xinghao, 12	Li, Yuan, 0V
Fu, Qiang, 07	Liang, Wenyao, 0A
Fu, Rulian, 0N	Liao, Zhibo, 0C
Gan, Xun, 0Q, 0T, 0U	Liu, Bing-qi, 0H
Gao, Runmei, 0N	Liu, Haibo, 1A
Gao, Shan, 0V	Liu, Kai, 0D
Gao, Shuai, 0J	Liu, Li, 0V
Guo, Limin, 03	Liu, Lu, 0J
Guo, Mingan, 0J	Liu, Youqiang, 03
Han, Shaochun, 0L	Lu, Weiguo, 0Y
Han, Xing, 16	Luo, Tongding, 0J
Hao, Qun, 0L	Lv, Juan, 0F
Hao, Yun-cai, 0M	Lv, Yanqiu, 0S
He, Mingzhao, 11	Ma, Bin, 16
He, Xuhua, 09, 0C	Ma, Xiaolong, 0F
He, Yinghong, 0F	Ma, Xuan, 02, 05
He, Yulan, 0V	Mao, Yao, 0Q, 0T, 0U
Hong, Keehoon, 0X	Mei, Chao, 0W, 15
Hong, Li-juan, 04	Miao, Dongjing, 11
Hu, BingLiang, 0Z	Miranda, Matheus, 0X
Hu, Shaolin, 0R	Mu, Quan-quan, 0E
Huang, Fu-yu, 0H	Ou, Jianliang, 05
Huang, Xiao, 0G	Qiang, Hua, 0V
Huang, Yifan, 16	Qiao, Mingrui, 0W
Jang, Yu, 0Q	Qu, Hemeng, 13
Jiang, Kai, 0D	Qu, Zhou, 10
Jiang, Yuanlin, 11	Shan, Qiusha, 0D
Jiao, Wenchun, 0C	Shang, Yang, 02, 05, 1A
Jin, Min, 04	Shen, Si, 0R
Kang, FuZeng, 0Z	Shi, Kui, 0W

Shi, PuRui, 16
 Shi, Zhengfeng, 0S
 Si, Junjie, 0S, 17
 Song, Junru, 09
 Song, Yong, 0L
 Su, Xianjun, 0S
 Sui, Xin, 10
 Sun, Weiguo, 17
 Tang, Xuehai, 12
 Tao, Sunjie, 0B
 Tian, Jing, 0T, 0U
 Wang, Haichao, 0C
 Wang, Hongju, 0B
 Wang, Li, 0M
 Wang, Ling, 0V
 Wang, Lingjie, 13
 Wang, Nanxi, 0V
 Wang, Wen-sheng, 07
 Wang, X. Z., 0O
 Wang, YanJun, 0Z
 Wang, Yu, 14
 Wang, Zefeng, 15
 Wang, Zhiyong, 03
 Wang, Zong You, 0Q
 Wei, Yongjing, 0Y
 Wu, B. Q., 0O, 0P
 Wu, Dengshan, 0W
 Wu, Tengfei, 14
 Wu, Yanxiong, 13
 Wu, Yiming, 0Y
 Xiao, Maosen, 0Y
 Xie, YongJun, 0Z
 Xing, Hui, 09
 Xu, Chun-mei, 0H
 Xu, Haifeng, 10
 Xu, Huan-yu, 0E
 Xu, Xiping, 06
 Xu, Zhiqiang, 02
 Xuan, Li, 0E
 Xue, Bin, 0F
 Yan, Aqi, 15
 Yan, Ming, 0J
 Yan, Pei-pei, 0D
 Yan, Xingtao, 0F
 Yang, Guanghui, 03
 Yang, Haifeng, 0B
 Yang, Hong, 0V
 Yang, Hongtao, 0W
 Yang, Hui, 0I
 Yang, Jianfeng, 0F
 Yang, Kun, 10
 Yang, Shaohua, 0J
 Yao, Guansheng, 17
 Yao, Jianquan, 0N
 Yao, Li-shuang, 0E
 Yao, Shun, 03
 Yin, QinYe, 0Z
 Yu, Huangzhong, 0A
 Zhang, Chu, 0H
 Zhang, Gaopeng, 0W, 15

Zhang, Guo-yu, 08
 Zhang, Jian, 08
 Zhang, Jizhen, 13
 Zhang, Jun, 0M
 Zhang, Kaisheng, 15
 Zhang, Liang, 17
 Zhang, Li-peng, 0I
 Zhang, Liping, 13
 Zhang, Lixue, 17
 Zhang, Pei-guang, 0E
 Zhang, Shaojun, 06
 Zhang, Su, 07
 Zhang, Teng-peng, 04
 Zhang, Xiaohui, 0K
 Zhang, Xin, 13
 Zhang, Yueqiang, 05, 1A
 Zhang, Yuxia, 0A
 Zhang, Zhaohui, 15
 Zhang, Zhi, 15
 Zhang, ZhouFeng, 0Z
 Zhao, Shangnan, 0L
 Zhao, Yiyi, 0F
 Zhao, Yufei, 0L
 Zhong, Wei, 0K
 Zong, Xiaoying, 0C

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Introduction

Applied Optics and Photonics, China (AOPC2015) is the annual conference of the Chinese Society for Optical Engineering, and it is also the largest academic and industrial event in the field of optical and optoelectronic technology in China. The AOPC2015 organization committee intended to build a cohesive platform for academic exchanges, industry exhibitions, and corporate negotiations. The conference had 7 themes, which included 22 technical conferences and 600 technical presentations. We sincerely hope that the research and development of optoelectronic technology was promoted, and that the international cooperation of the optical and optoelectronic industry was enhanced.

AOPC2015 was sponsored by the Chinese Society for Optical Engineering; SPIE, the Optical Society, the European Optical Society, and the Optical Society of Korea were technical co-sponsors. There were also 28 cooperating organizations that supported the conference. We received a total of 1,219 contributions from more than 15 countries, including: the United States, the United Kingdom, Germany, France, Spain, Australia, Canada, Mexico, Brazil, Japan, Republic of Korea, Thailand, Singapore, Russian Federation, and China. Nearly 700 submissions were accepted for the *Proceedings of SPIE*, and over 150 invited talks and papers were suggested to be published in Journals indexed by SCI and Ei. After careful discussion, we selected five plenary speeches, which were presented by famous scientists from the United States, the United Kingdom, Republic of Korea, Japan, and China. There were 205 invited talks in 12 of the technical conferences. On behalf of the organization committee of AOPC, I express thanks to all of the invited speakers and authors for their contributions to and support of the conference.

To celebrate the International Year of Light 2015, we set up 12 display boards highlighting IYL in the exhibition area on the first level. These display boards were to educate the public about light and the applications of light in society.

Finally, on behalf of Prof. Songlin Zhuang, the other co-chairs, and the organization committee of AOPC, I would like to heartily thank our sponsors and cooperating organizations for all they have done for the conference. I thank all of the participants and friends for their interest and efforts in helping us make the conference a success. I also thank the program committee for their effective work and valuable advice—especially the AOPC2015 secretariat and the SPIE staff for their tireless effort and outstanding services in preparing the conference and publishing the proceedings.

Again, we extend our warmest greetings to you and hope you had a pleasant and exciting stay in Beijing!

Guofan Jin